AF/IFU

AMENDMENT TRANSMITTAL LETTER (Large Entity) Applicant(s): Jack O. Chu et al.						Docket No. YOR920010308US3 (16315B)	
Application No. 10/775,514	Filing Date February 10, 2004	Examiner Johannes P. Mond	lt	Customer N 23389	o.	Group Art Unit 2826	Confirmation No.
Invention: EPITAXIAL AND POLYCRYSTALLINE GROWTH OF Si1-x-y GexCy AND Si1-yCy ALLOX LRYERS ON Si BY UHV-CVD							
COMMISSIONER FOR PATENTS:  Transmitted herewith is an amendment in the above-identified application.  The fee has been calculated and is transmitted as shown below.							
CLAIMS AS AMENDED							
	CLAIMS REMAINING AFTER AMENDMENT	HIGHEST #		ER EXTRA	RATE		ADDITIONAL FEE
TOTAL CLAIMS	9 -	32 =			X	\$50.00	\$0.00
INDEP. CLAIMS	2 -	4 =		0	X	\$200.00	\$0.00
Multiple Dependent Claims (check if applicable)							\$0.00
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT \$0.0							\$0.00
<ul> <li>No additional fee is required for amendment.</li> <li>□ Please charge Deposit Account No. in the amount of</li> <li>□ A check in the amount of to cover the filing fee is enclosed.</li> <li>☑ The Director is hereby authorized to charge payment of the following fees associated with this communication or credit any overpayment to Deposit Account 50-0510/IBM</li> <li>☑ Any additional filing fees required under 37 C.F.R. 1.16.</li> <li>☑ Any patent application processing fees under 37 CFR 1.17.</li> <li>□ Payment by credit card. Form PTO-2038.</li> <li>WARNING: Information on this form may become public. Credit card information should not be included on this form. Provide credit card information and authorization on PTO-2038.</li> </ul>							
Leslie S. Szivos, Ph Registration No. 39 SCULLY, SCOTT 400 Garden City P Garden City, New	I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to "Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450" [37 CFR 1.8(a)] on December 5, 2005  (Date)						

cc:

Signature of Person Mailing Correspondence
Leslie S. Szivos, Ph.D.

Typed or Printed Name of Person Mailing Correspondence





Response Under 37 C.F.R.§1.116 Examining Group 2826 Expedited Procedure

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s):

Jack O. Chu, et al.

Examiner:

Johannes P. MONDT

Serial No:

10/775,514

**Art Unit:** 

2826

Filed:

February 10, 2004

Docket: YOR920010308US3 (16315B)

For: EPITAXIAL AND POLYCRYSTALLINE

Dated:

December 5, 2005

GROWTH OF Si<sub>1-x-y</sub> Ge<sub>x</sub>C<sub>y</sub> AND Si<sub>1-y</sub>C<sub>y</sub> ALLOY LAYERS ON Si BY UHV-CVD

**Confirmation Number: 1038** 

Mail Stop AF Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

## **RESPONSE UNDER 37 C.F.R. § 1.116**

Sir:

In response to the Final Office Action dated October 3, 2005, Applicants hereby submit the following amendments and remarks for entry of record in the above-identified patent application.

## CERTIFICATE OF MAILING UNDER 37 C.F.R. §1.8(a)

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to Mail Stop AF, Commissioner of Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on December 5, 2005

Dated: December 5, 2005

Leslie S. Szivos, Ph.D.